JUL 0 2 2001 DECLARATION AN



As a below, named inventor, I hereby declare that my residence, post office address and citizenship are as stated below next to my name, and I believe 10 in the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

METHOD OF FORMING SILICON OXIDE FILM AND FORMING APPARATUS THEREOF

the specification of which (check one)			
( ) is attached hereto: (x) was filed on $3/27/20$	01 as United States Applicati	ion Number or PCT Internationa	Application Number 09/818,972
on, and was amende	ed on (if ap	oplicable).	
I hereby state that I have reviewed and un amendment referred to above. I acknowle Federal Regulation, §1.56. I hereby claim for patent or inventor's certificate listed be disclosing the subject matter claimed in the or (2) if no priority is claimed, before the	edge the duty to disclose inform n foreign priority benefits under elow and have also identified be neir application and having a fil	nation which is material to patent r Title 35, United States Code, § elow any foreign application for	tability as defined in Title 37, Code of 119/365 of any foreign application(s) patent or inventor's certificate
Prior foreign Application(s)			
Numb <u>er</u>	Country	Day/Month/Year Filed	Priority Claimed
211005/2000	Japan	12/7/2000	(x) Yes ( ) No
			( ) Yes ( ) No
			( ) Yes ( ) No
States application in the manner provided information which is material to patentabi filing date of the prior application and the (Application Number)	ility as defined in Title 37, Cod national or PCT international f	e of Federal Regulations, §1.56	which became available between the
I hereby appoint Donald W. Muirhead, Reprosecute this application and to transact	eg. No. 33,978; Anne E. Saturn	elli, Reg. No. 41,290; and David rademark Office connected there	I Suhl, Reg. No. 43,169 as attorneys to ewith.
Address all telephone calls to Donald W. Muirhead at telephone number (617) 951-6676. Address all correspondence to:			
	Patent Group Hutchins, W 101 Federal Boston, MA	heeler & Dittmar Street	
I hereby declare that all statements made believed to be true; and further that these punishable by fine or imprisonment, or be jeopardize the validity of the application of	statements were made with the oth, under Section 1001 of Title or any patent issued thereon.	knowledge that willful false state 18 of the United States Code ar	tements and the like so made are nd that such willful false statements may
Inventor's signature Kats	nhisa Yuda		Date June 25, 2001
Full name of sole or first inventor (given	name, family name)KAT	SUHISA YUDA	
Residence Tokyo, Japan		C	itizenship Japanese
Post Office Address (include zip code)	c/o NEC Corporation	. 7-1. Shiba.5-chome	e, Minato-ku,
	Tokyo, Japan		
Inventor's signature Ce	Olu		Date June 25, 2001
Full name of second inventor (given name	e, family name)GE_XU		
Residence Tokyo, Japan		c	itizenship Chinese
Post Office Address (include zip code) c/o ANELVA Corporation, 5-8-2, Yotsuya, Fuchu-shi,  Tokyo, Japan			
( ) Additional inventors are being named on separately numbered sheets attached hereto.			